

#4

F

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Yoshihiro OHMI et al

Serial Number: 09/864,376

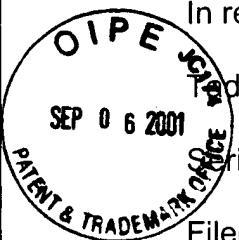
Filed: May 25, 2001

For: PLASMA PROCESSING APPARATUS AND
PLASMA PROCESSING METHOD

ATTN: Application Branch

Confirmation No.: 1605

Atty. Docket No.: 107176-00007



REQUEST FOR CORRECTED FILING RECEIPT

Honorable Commissioner for Patents
Washington, D.C. 20231

September 6, 2001

RECEIVED
SEP 25 2001
TC 1700

Sir:

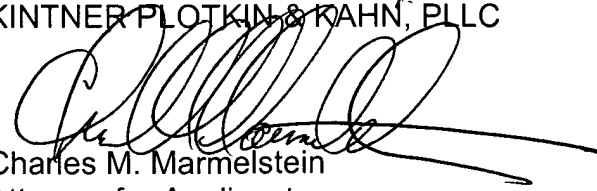
Please supply the undersigned attorney with a corrected filing receipt of the above-identified application.

In reviewing the Official Filing Receipt, we noted an error in the second inventor's name. The second inventor's name should read -- Kazuhide INO --. In support of this request, enclosed is a copy of Declaration and Power of Attorney, along with a copy of the filing receipt with the correction highlighted in yellow.

In the event any fees are due with respect to this paper, please charge our Deposit Account No. 01-2300.

Respectfully submitted,

ARENT FOX KINTNER PLOTKIN & KAHN, PLLC


Charles M. Marmelstein
Attorney for Applicants
Reg. No. 25,895

1050 Connecticut Avenue
Suite 400
Washington, D.C. 20036-5339
Tel (202) 857-6000
Fax (202) 638-4810

CMM:mmg

Enclosures: Declaration and Power of Attorney (copy); Official Filing Receipt (copy)



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/864,376	05/25/2001	1763	0.00	107176-00007	4	8	2

CONFIRMATION NO. 1605

FILING RECEIPT



OC000000006348961

ARENT FOX KINTNER PLOTKIN & KAHN, PLLC
Suite 600
1050 Connecticut Avenue, N.W.
Washington, DC 20036-5339

Date Mailed: 07/26/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

Tadahiro Ohmi, Sendai-shi, JAPAN;
Kazuhide Kazuhide Ino, Kyoto-shi, JAPAN;
Takahiro Arakawa, Kyoto-shi, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2000-156535 05/26/2000

If Required, Foreign Filing License Granted 07/26/2001

Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Plasma processing apparatus and plasma processing method

Preliminary Class

RECEIVED
SEP 25 2001
TC 1700

REVIEWED IN
DOCKETING BY
DATE 7-31-01

156

Data entry by : ASRAT, FANAYE

Team : OIPE

Date: 07/26/2001



UNITED STATES PATENT AND TRADEMARK OFFICE

FILE COPY

 COMMISSIONER FOR PATENTS
 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20231
 www.uspto.gov


Bib Data Sheet

CONFIRMATION NO. 1605

SERIAL NUMBER 09/864,376	FILING DATE 05/25/2001 RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 107176-00007
------------------------------------	---	---------------------	-------------------------------	--

APPLICANTS

Tadahiro Ohmi, Sendai-shi, JAPAN;
 Kazuhide Ino, Kyoto-shi, JAPAN;
 Takahiro Arakawa, Kyoto-shi, JAPAN;

** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2000-156535 05/26/2000

RB 9/4/02

 RECEIVED
 SEP 25 2001
 TC 1700

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/26/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: _____				

ADDRESS

PARENT FOX KINTNER PLOTKIN & KAHN, PLLC
 Suite 600-400
 1050 Connecticut Avenue, N.W.
 Washington, DC 20036-5339

TITLE

Plasma processing apparatus and plasma processing method

FILING FEE RECEIVED 840	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit